



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 9014

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/540,992		438	1792	061063-0316598

APPLICANTS

Jea Gun Park, Seognam-city, KOREA, REPUBLIC OF;
 Un Gyu Paik, Seoul, KOREA, REPUBLIC OF;
 Jin Hyung Park, Ulsan-city, KOREA, REPUBLIC OF;
 Takeo Katoh, Seoul, KOREA, REPUBLIC OF;

**** CONTINUING DATA *******

This application is a 371 of PCT/JP03/16813 12/25/2003

**** FOREIGN APPLICATIONS *******

REPUBLIC OF KOREA 10-2002-0087934 12/31/2002

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

07/21/2006

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input type="checkbox"/> Yes <input type="checkbox"/> No		KOREA, REPUBLIC OF	10	17	1

ADDRESS

PILLSBURY WINTHROP SHAW PITTMAN, LLP
 P.O. BOX 10500
 MCLEAN, VA 22102
 UNITED STATES

TITLE

Chemical-mechanical-polishing slurry composition, method for planarizing surface of semiconductor device using the same, and method for controlling selection ratio of slurry composition

FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit